

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---------------|------------|-------------|-----------|
| Applicant:    | Lu et al.  | Art Unit:   | 2826      |
| Serial No.:   | 10/722,013 | Examiner:   | Erdem, F. |
| Filing Date:  | 11/25/2003 | Docket No.: | TI-35669  |
| Customer No.: | 23494      | Conf. No.:  | 6979      |

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER  
AND A METHOD OF MANUFACTURE THEREFOR

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATION OF TRANSMISSION

I hereby certify that the following papers are being electronically transmitted to the U.S. Patent and Trademark Office on 12/11/2006.

/Jacqueline J Garner/  
Jacqueline J. Garner  
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated July 11, 2006. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification**.

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 7.